

Docket No.: 1592-0169PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Takashi OZAKI et al.

Application No.: 10/549,938

Confirmation No.: 7521

Filed: January 3, 2007

Art Unit: 2895

For: PRODUCING METHOD OF
SEMICONDUCTOR DEVICE AND
SUBSTRATE PROCESSING APPARATUS

Examiner: C. Everhart

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the representative named below be advised of the status of the Request for Certificate of Correction filed on June 1, 2009. Please advise us of when we might expect to receive the Certificate of Correction from the Patent and Trademark Office.

Dated: MAY 25 2010

Respectfully submitted,

By  4/8/10

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